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**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor's Application of

Attn: OIPE

Yasushi OKUBO et al.

Group Art Unit: 2812

Application No.: 10/551,136

Docket No.: 125493

Filed: January 5, 2006

For: MASK BLANK, MANUFACTURING METHOD OF MASK BLANK,  
MANUFACTURING METHOD OF TRANSFER MASK AND MANUFACTURING  
METHOD OF SEMICONDUCTOR DEVICE

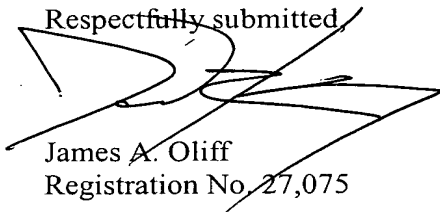
**REQUEST FOR CORRECTION OF PALM RECORDS**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Attached is a photocopy of the original filing receipt on which errors have been corrected in red. These errors are being brought to the attention of the Patent and Trademark Office so that it may correct its records. A Supplemental Application Data Sheet is attached.

Respectfully submitted,



James A. Oliff  
Registration No. 27,075

David R. Kemeny  
Registration No. 57,241

JAO:DRK/lah

Date: March 5, 2007

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<p>DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461</p>
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## UNITED STATES PATENT AND TRADEMARK OFFICE

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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/551,136	01/05/2006	2812	1360	125493	6	9	4

CONFIRMATION NO. 4314

## FILING RECEIPT



\*OC000000022364997\*

25944  
OLIFF & BERRIDGE, PLC  
P.O. BOX 19928  
ALEXANDRIA, VA 22320

Date Mailed: 02/26/2007

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please mail to the Commissioner for Patents P.O. Box 1450 Alexandria Va 22313-1450. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

## Applicant(s)

Yasushi Okubo, Tokyo, JAPAN;  
Yasunori Yokoya, Tokyo, JAPAN;

## Assignment For Published Patent Application

HOYA CORPORATION, TOKYO, JAPAN

**Power of Attorney:** The patent practitioners associated with Customer Number **25944**.

## Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP04/04617 03/31/2004

## Foreign Applications

JAPAN 2003-096910 03/31/2003

*Corrections  
on 2nd page*

**If Required, Foreign Filing License Granted:** 02/06/2007

**The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is** **US10/551,136**

**Projected Publication Date:** 05/17/2007

**Non-Publication Request:** No

Early Publication Request: No

**Title** Mask blank, manufacturing method of mask blank, manufacturing method of transfer mask and manufacturing method of semiconductor device.  
~~Mask blank, mask blank manufacturing method, transfer mask manufacturing method, and semiconductor device manufacturing method~~

Preliminary Class

482

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ATTORNEYS AT LAW

## Supplemental Application Data Sheet

### Applicant Information

Applicant Authority type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
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Applicant Authority Type::	Inventor
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### Correspondence Information

Correspondence Customer Number::	25944
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### Application Information

Application Type::	National Phase
Subject Matter::	Utility
CD-ROM or CD-R::	None
Title::	<del>MASK BLANK, MASK BLANK-</del> <del>MANUFACTURING METHOD, TRANSFER-</del> <del>MASK MANUFACTURING METHOD, AND</del> <del>SEMICONDUCTOR DEVICE-</del> <del>MANUFACTURING METHOD</del> <u>MASK BLANK, MANUFACTURING METHOD OF</u> <u>MASK BLANK, MANUFACTURING</u> <u>METHOD OF TRANSFER MASK AND</u> <u>MANUFACTURING METHOD OF</u> <u>SEMICONDUCTOR DEVICE.</u>

Attorney Docket Number::	125493
Suggested Drawing Figure::	

Total Drawing Sheets:: 6  
Small Entity:: No

### Representative Information

Attorneys associated with Customer No. 25944.

<b>Domestic Priority Information</b>			
Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application is a	National Stage of	PCT/JP2004/004617	03/31/2004
<b>Foreign Priority Information</b>			
Country::	Application Number::	Filing Date::	Priority Claimed::
JAPAN	2003-096910	03/31/2003	Yes
<b>Assignee Information</b>			
Assignee Name::		HOYA CORPORATION	
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Postal or Zip Code of mailing address::		161-8525	